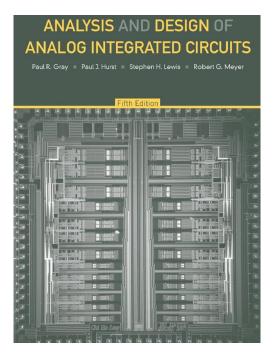
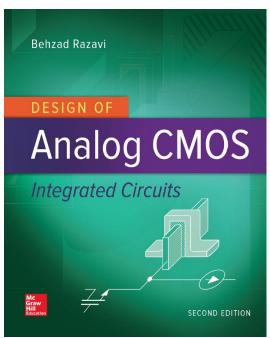
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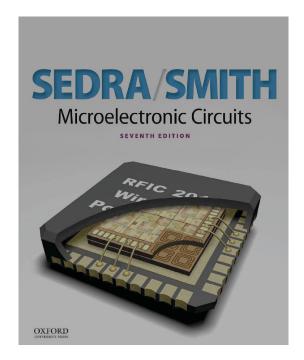
FOURTH EDITION CMOS DESIGN A CIRCUITS AND SYSTEMS PERSPECTIVE NEIL H. E. WESTE DAVID MONEY HARRIS

مرجع اصلي

مراجع دیگر:







آموزش الکترونیک دیجیتال پیشرفته فرادرس مهندس پرستو عظیمی

Lecture 0: Introduction

Introduction

- ☐ Integrated circuits: many transistors on one chip.
- □ Very Large Scale Integration (VLSI): bucketloads!
- Complementary Metal Oxide Semiconductor
 - Fast, cheap, low power transistors
- □ Today: How to build your own simple CMOS chip
 - CMOS transistors
 - Building logic gates from transistors
 - Transistor layout and fabrication
- ☐ Rest of the course: How to build a good CMOS chip

Silicon Lattice

- ☐ Transistors are built on a silicon substrate
- Silicon is a Group IV material
- Forms crystal lattice with bonds to four neighbors

Dopants

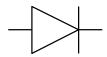
- ☐ Silicon is a semiconductor
- Pure silicon has no free carriers and conducts poorly
- Adding dopants increases the conductivity
- □ Group V: extra electron (n-type)
- Group III: missing electron, called hole (p-type)

p-n Junctions

- □ A junction between p-type and n-type semiconductor forms a diode.
- Current flows only in one direction

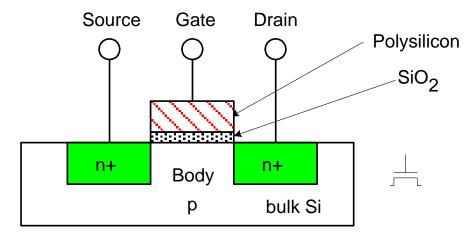
p-type n-type

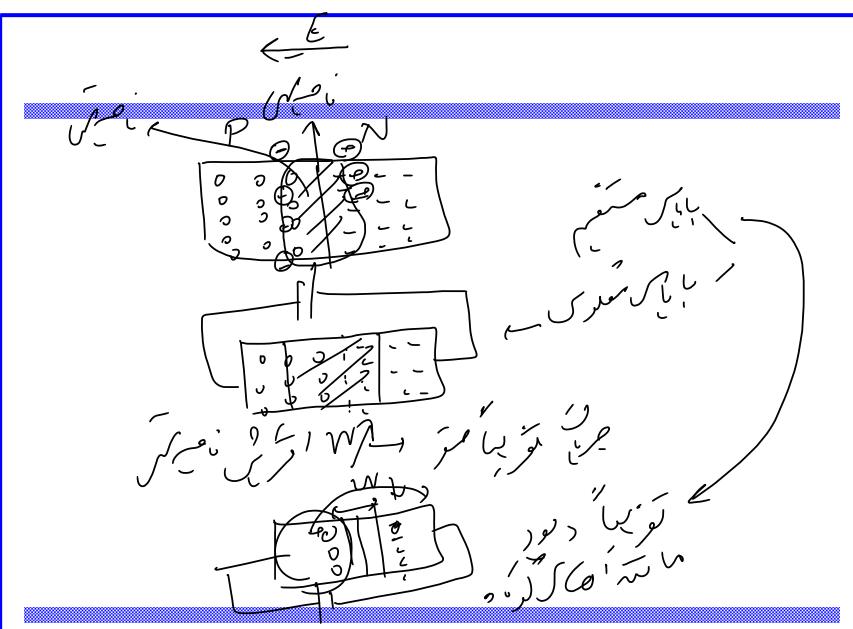
anode cathode



nMOS Transistor

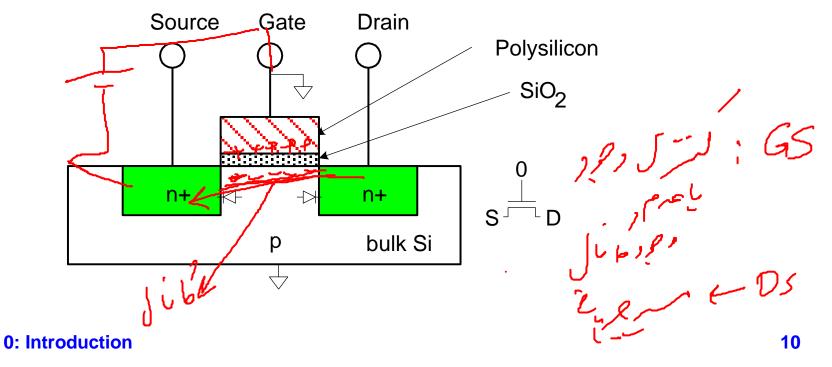
- ☐ Four terminals: gate, source, drain, body
- ☐ Gate oxide body stack looks like a capacitor
 - Gate and body are conductors
 - SiO₂ (oxide) is a very good insulator
 - Called metal oxide semiconductor (MOS)capacitor
 - Even though gate is no longer made of metal*
 - * Metal gates are returning today!





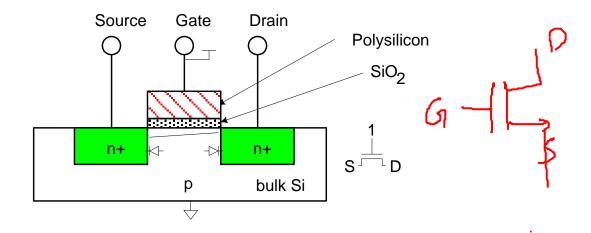
nMOS Operation

- ☐ Body is usually tied to ground (0 V)
- ☐ When the gate is at a low voltage:
 - P-type body is at low voltage
 - Source-body and drain-body diodes are OFF
 - No current flows, transistor is OFF



nMOS Operation Cont.

- When the gate is at a high voltage:
 - Positive charge on gate of MOS capacitor
 - Negative charge attracted to body
 - Inverts a channel under gate to n-type
 - Now current can flow through n-type silicon from source through channel to drain, transistor is ON



pMOS Transistor

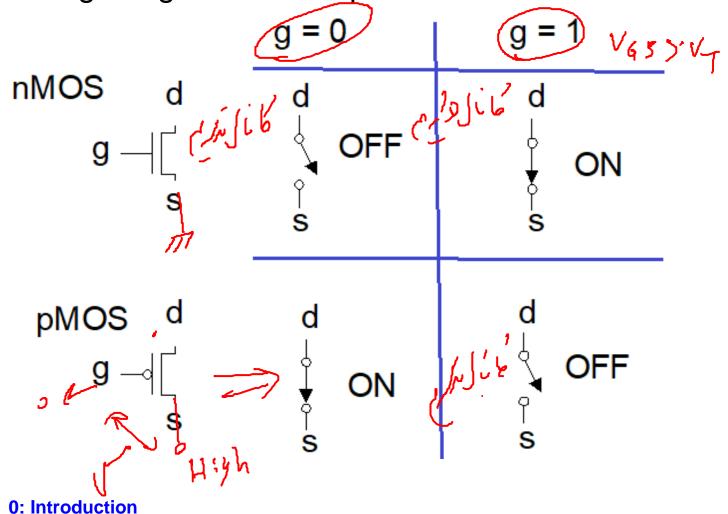
- Similar, but doping and voltages reversed
 - Body tied to high voltage (V_{DD})
 - Gate low: transistor ON
 - Gate high: transistor OFF

Power Supply Voltage

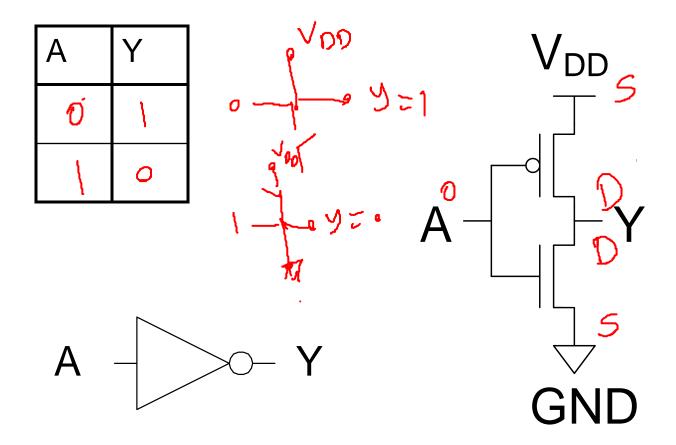
- \Box GND = 0 V
- \Box In 1980's, $V_{DD} = 5V$
- V_{DD} has decreased in modern processes
 - High V_{DD} would damage modern tiny transistors
 - Lower V_{DD} saves power
- \square $V_{DD} = 3.3, 2.5, 1.8, 1.5, 1.2, 1.0, ...$

Transistors as Switches

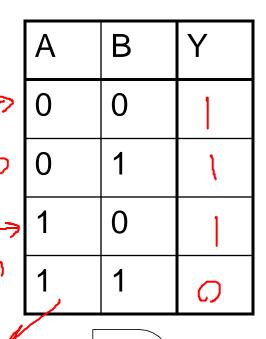
- MOS transistors can view as electrically controlled switches
- Voltage at gate controls path from source to drain

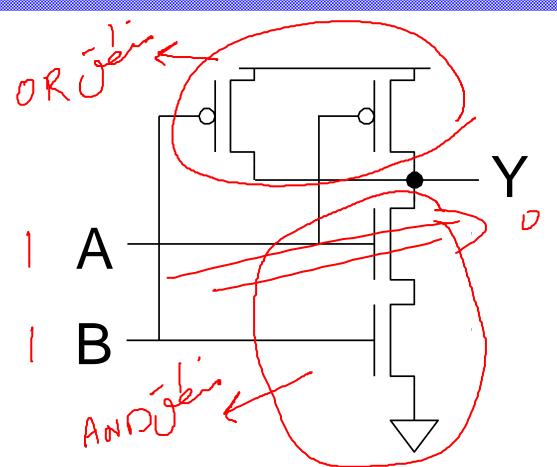


CMOS Inverter



CMOS NAND Gate



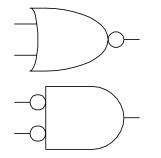


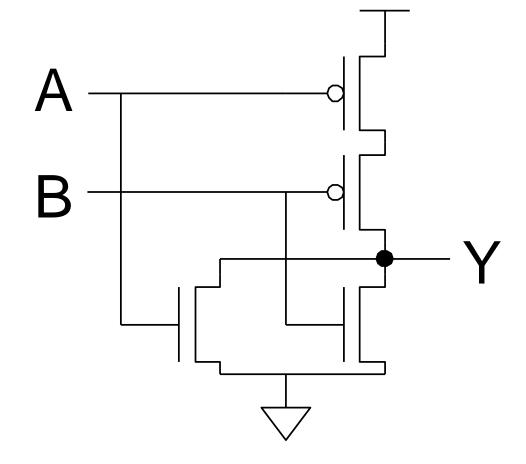
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CMOS NOR Gate

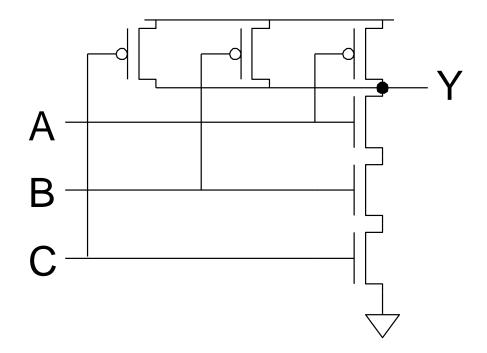
Α	В	Υ
0	0	1
0	1	0
1	0	0
1	1	0





3-input NAND Gate

- ☐ Y pulls low if ALL inputs are 1
- ☐ Y pulls high if ANY input is 0



$$F = A (B + CD)$$

$$F = \overline{A} + (\overline{B} \cdot CC + \overline{D}))$$

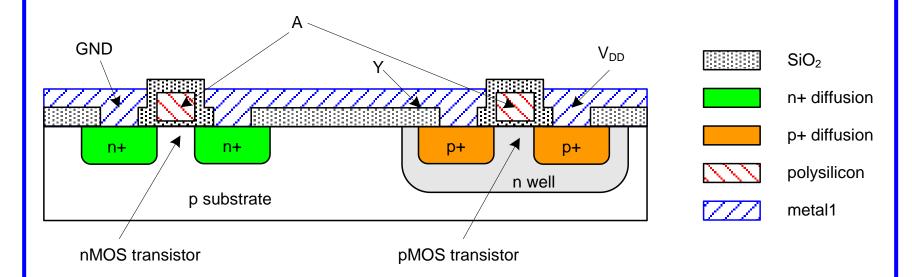
$$A = \overline{A} + \overline{$$

CMOS Fabrication

- ☐ CMOS transistors are fabricated on silicon wafer
- ☐ Lithography process similar to printing press
- On each step, different materials are deposited or etched
- Easiest to understand by viewing both top and cross-section of wafer in a simplified manufacturing process

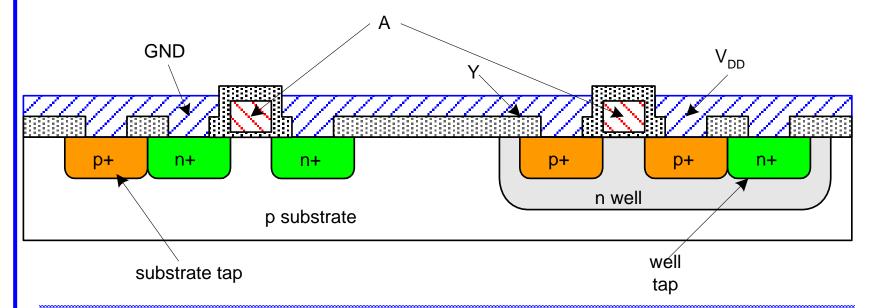
Inverter Cross-section

- ☐ Typically use p-type substrate for nMOS transistors
- □ Requires n-well for body of pMOS transistors



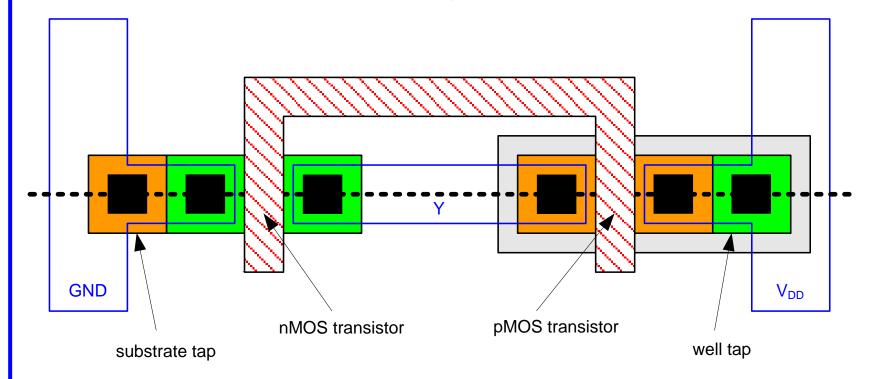
Well and Substrate Taps

- ☐ Substrate must be tied to GND and n-well to V_{DD}
- Metal to lightly-doped semiconductor forms poor connection called Shottky Diode
- ☐ Use heavily doped well and substrate contacts / taps



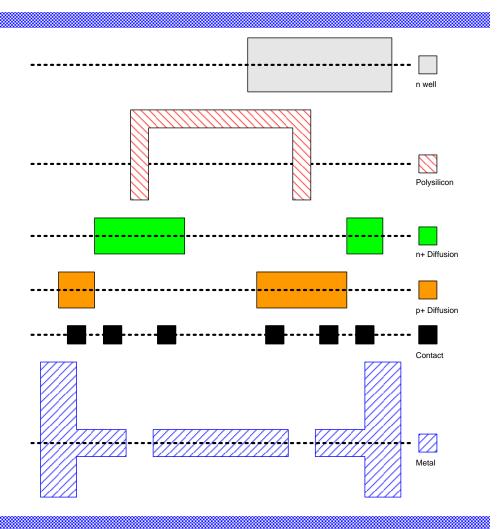
Inverter Mask Set

- ☐ Transistors and wires are defined by *masks*
- Cross-section taken along dashed line



Detailed Mask Views

- □ Six masks
 - n-well
 - Polysilicon
 - n+ diffusion
 - p+ diffusion
 - Contact
 - Metal



Fabrication

- ☐ Chips are built in huge factories called fabs
- ☐ Contain clean rooms as large as football fields



Courtesy of International Business Machines Corporation. Unauthorized use not permitted.

Fabrication Steps

- ☐ Start with blank wafer
- Build inverter from the bottom up
- First step will be to form the n-well
 - Cover wafer with protective layer of SiO₂ (oxide)
 - Remove layer where n-well should be built
 - Implant or diffuse n dopants into exposed wafer
 - Strip off SiO₂

p substrate

Oxidation

- ☐ Grow SiO₂ on top of Si wafer
 - 900 1200 C with H₂O or O₂ in oxidation furnace

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P substrate
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Photoresist

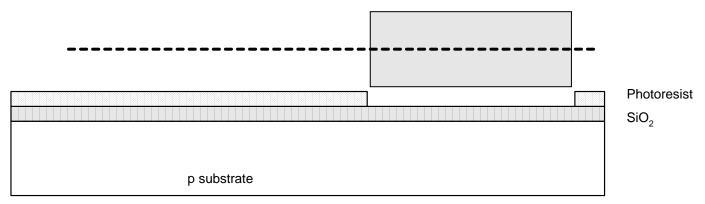
- □ Spin on photoresist
 - Photoresist is a light-sensitive organic polymer
 - Softens where exposed to light

p substrate

Photoresist SiO₂

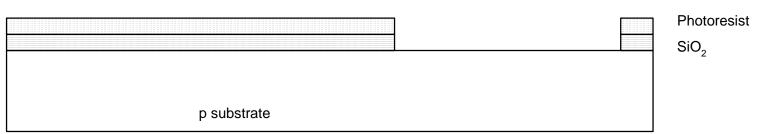
Lithography

- □ Expose photoresist through n-well mask
- Strip off exposed photoresist



Etch

- ☐ Etch oxide with hydrofluoric acid (HF)
 - Seeps through skin and eats bone; nasty stuff!!!
- Only attacks oxide where resist has been exposed



Strip off Photoresist

- Use mixture of acids called piranah etch
- Necessary so resist doesn't melt in next step



n-well(diffusion or ion implantation)

- Diffusion
 - Place wafer in furnace with arsenic gas
 - Heat until As atoms diffuse into exposed Si
- Ion Implanatation
 - Blast wafer with beam of As ions.
 - lons blocked by SiO₂, only enter exposed Si

SiO₂ n well

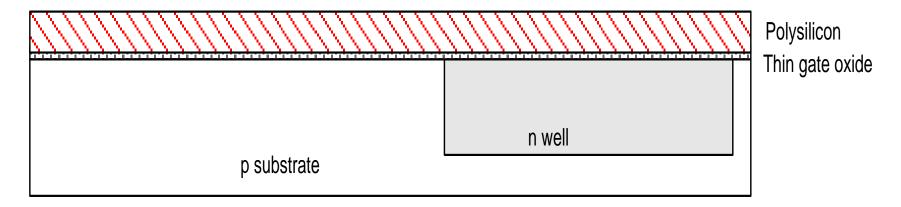
Strip off Oxide(using HF)

- Back to bare wafer with n-well
- ☐ Subsequent steps involve similar series of steps

n well p substrate

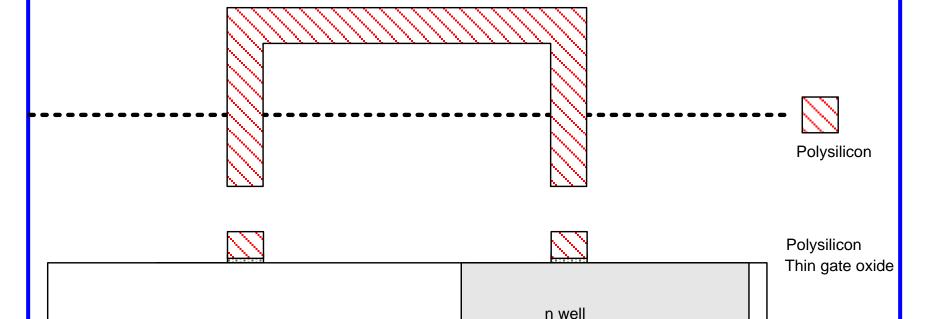
Polysilicon

- Deposit very thin layer of gate oxide
 - < 20 Å (6-7 atomic layers)</p>
- □ Chemical Vapor Deposition (CVD) of silicon layer
 - Place wafer in furnace with Silane gas (SiH₄)
 - Forms many small crystals called polysilicon
 - Heavily doped to be good conductor



Polysilicon Patterning

☐ Use same lithography process to pattern polysilicon



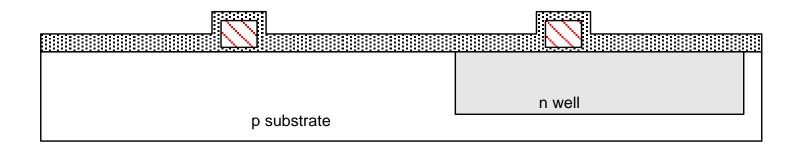
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p substrate

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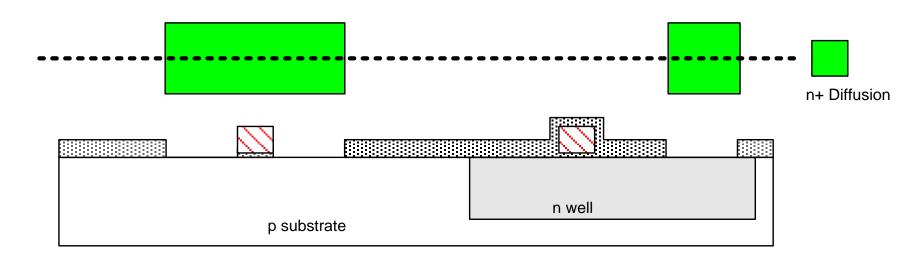
Self-Aligned Process

- ☐ Use oxide and masking to expose where n+ dopants should be diffused or implanted
- N-diffusion forms nMOS source, drain, and n-well contact



N-diffusion

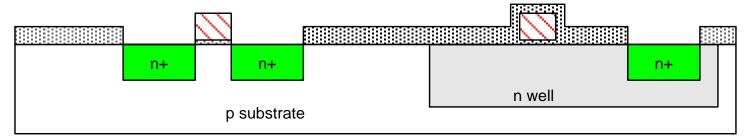
- □ Pattern oxide and form n+ regions
- ☐ Self-aligned process where gate blocks diffusion
- □ Polysilicon is better than metal for self-aligned gates because it doesn't melt during later processing



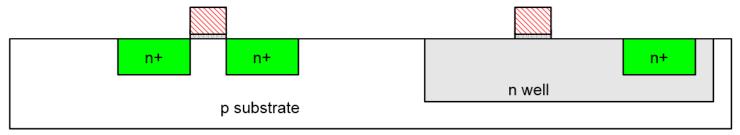
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N-diffusion cont.

- ☐ Historically dopants were diffused
- Usually ion implantation today
- But regions are still called diffusion

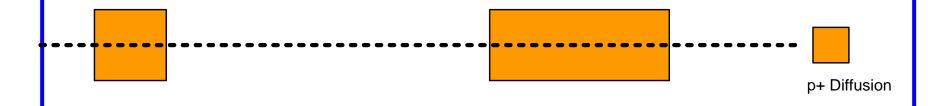


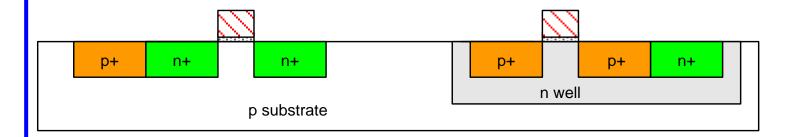
Strip off oxide to complete patterning step



P-Diffusion

☐ Similar set of steps form p+ diffusion regions for pMOS source and drain and substrate contact





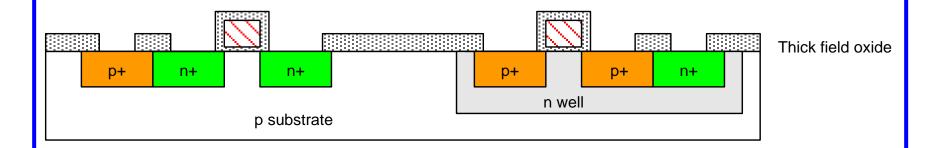
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Contacts

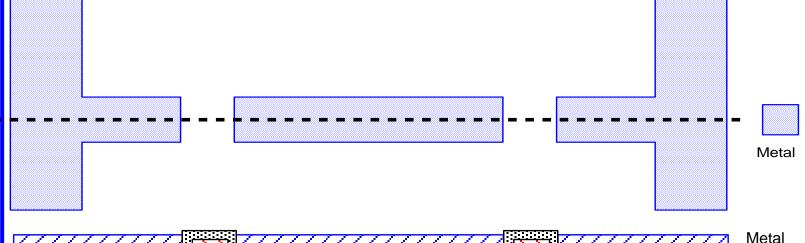
- Now we need to wire together the devices
- Cover chip with thick field oxide
- Etch oxide where contact cuts are needed





Metalization

- ☐ Sputter on aluminum over whole wafer
- ☐ Pattern to remove excess metal, leaving wires



p+ n+ n+ p+ p+ n+ n well
p substrate

Thick field oxide

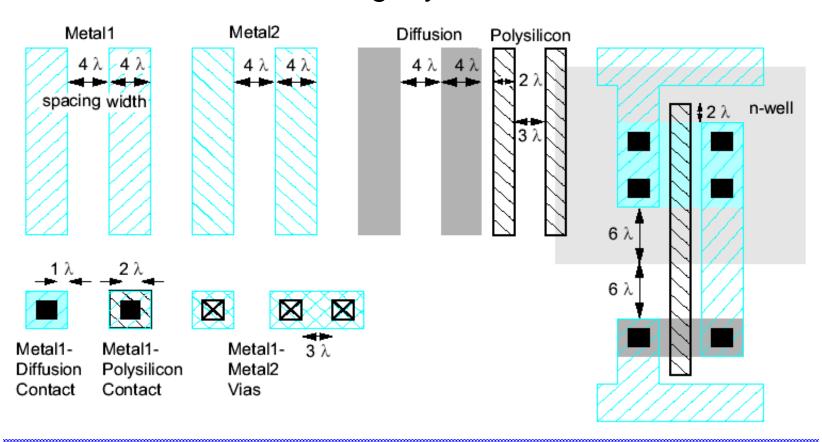
THICK HEIG OXIGE

Layout

- ☐ Chips are specified with set of masks
- Minimum dimensions of masks determine transistor size (and hence speed, cost, and power)
- \Box Feature size f = distance between source and drain
 - Set by minimum width of polysilicon
- ☐ Feature size improves 30% every 3 years or so
- Normalize for feature size when describing design rules
- \square Express rules in terms of $\lambda = f/2$
 - E.g. λ = 0.3 μ m in 0.6 μ m process

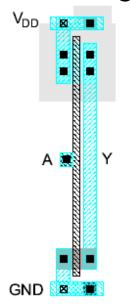
Simplified Design Rules

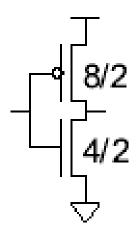
Conservative rules to get you started

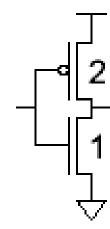


Inverter Layout

- ☐ Transistor dimensions specified as Width / Length
 - Minimum size is $4\lambda / 2\lambda$, sometimes called 1 unit
 - In f = 0.6 μ m process, this is 1.2 μ m wide, 0.6 μ m long







Summary

- MOS transistors are stacks of gate, oxide, silicon
- Act as electrically controlled switches
- Build logic gates out of switches
- Draw masks to specify layout of transistors
- Now you know everything necessary to start designing schematics and layout for a simple chip!